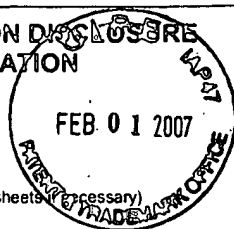


Sheet 1 of 2

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*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AN	2004/0263185	12/2004	Cho et al.	324	636	
	2004/0114913	06/2004	Kume	386	125	
	2003/0053400	03/2003	Cho et al.	369	126	
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	2003/0021213	01/2003	Hagiwara, Yoshiaki	369	101	
	4,320,491	03/1982	Rustman, James C.	369	126	
	5,418,029	05/1995	Yamamoto et al.	428	64.2	
	5,481,527	01/1996	Kasanuki et al.	369	126	
	5,646,932	07/1997	Kuribayashi et al.	369	126	
	5,751,685	05/1998	Yi, You-Wen	369	126	
	5,914,920	06/1999	Yokogawa	369	275.3	
	5,946,284	08/1999	Chung et al.	369	126	
	6,477,132	11/2002	Azuma et al.	369	126	
	6,510,130	01/2003	Hayashi et al.	369	275.3	
	6,515,957	02/2003	Newns et al.	369	126	
	6,653,630	11/2003	Rosenman et al.	250	306	
	6,762,402	07/2004	Choi et al.	250	234	
	6,841,220	01/2005	Onoe et al.	428	66.7	
	6,912,193	06/2005	Cho et al.	369	126	
	6,965,545	11/2005	Hino et al.	369	13.54	
	7,065,033	06/2006	Onoe et al.	369	126	
AN	7,149,180	12/2006	Onoe et al.	369	276	

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AN	2003085969	03/2003	JP			ABSTRACT
AN	08-075806	03/1996	JP			ABSTRACT
AN	10-334525	12/1998	JP			ABSTRACT
AN	56-107338	08/1981	JP			ABSTRACT

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AN	62th Japan Society of Applied Physics Lecture Meeting (2001.9 Aichi Institute of Technology) 12p-ZR-2.
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Date Considered

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AN	5,488,602	01/1996	Yamano et al.	369	126	
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	20020131669	09/2002	Onoe et al.	385	14	
	20020118906	08/2002	Onoe	385	14	
AN	20020105249	08/2002	Yoshida et al.	310	311	

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AN	57-200956	12/1982	JP			ABSTRACT	
AN	1 484 256	09/1977	GB				

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AN	Kazuta et al, "Determination of crystal polarities of piezoelectric thin film using scanning nonlinear dielectric microscopy", Journal of European Ceramic Society 21 (2001) 1581-1584.
AN	The Institution of Electrical Engineers, Stevenage, GB; 1 June 2002; Hiranaga et al, "Nano-sized inverted domain formation in stoichiometric LiTaO ₃ /single crystal using Scanning Nonlinear Dielectric Microscopy", XP002292217.
AN	Cho et al, "Scanning nonlinear dielectric microscopy with nanometer resolution", Journal of European Ceramic Society 21 (2001) 2131-2134.
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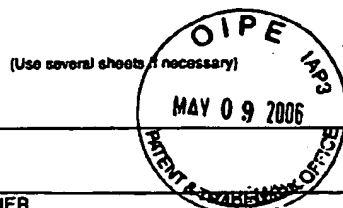
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DOCUMENT							TRANSLATION	
	DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO	
AN	I 369 864 A	12/2003	EP	—	—			
AN	I 381 042 A	1/2004	EP	—	—			

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